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	INFORMATION DISCLOSURE STATEMENT BY APPLICANT				Application Number	09/773,674	
					Filing Date	February 2, 2001	
					First Named Inventor	RICHARDSON	_
					Art Unit	2877	
•		(Use as many she	ets as	necessary)	Examiner Name	BARTH, Vincent P.	
	Sheet	1.	of	1	Attorney Docket Number	31655-2029	

		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials *	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T 2
加	N1	F. A. Norbert, "The Great Age of the Microscope", Gerard L'E Turner, 1989, First Edition, published by the Royal Microscopical Society, pages 344-345.	
1	N2	F. A. Norbert, "Micrographia HistoricaThe Study of the History of the Microscope", 1972, published by the Royal Microscopical Society, pages 20-24.	
	N3	Rudolf Oldenburg et al. in, "Standard Test Targets For High-Resolution Light Microscopy", Nanofabrication and Biosystems, Cambridge University Press, 1996, pages 123-138.	
	N4	"Image sharpness and contrast transfer in coherent confocal microscopy", Journal of the Royal Microscopical Society, 172, pages 31-39, 1993.	
1	N5	Japanese Patent No. 07 31 88 12 with English Abstract in the name of Hayashi issued December 8, 1995.	
AND	N6	Japanese Patent No. 08 02 93 30 with English Abstract in the name of Myata et al. issued February 2, 1996.	

Examiner Signature	Date Considered	7/9/2005	

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